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Confirmation Letter

To, Kirti Kedarnath Kadam Published in : Volume 8 | Issue 3 | 2021-03-10



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research .

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With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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